U.S. DEPARTMENT OF COMMERCE APPLICATION NO. FORM PTO-1449 ATTY, DOCKET NO. PATENT AND TRADEMARK OFFICE MICRON.278A 10/782,997 MATION DISCLOSURE STATEMENT BY APPLICANT APPLICANT 4AY 1 0 2004 Smythe et al. SEVERAL SHEETS IF NECESSARY) FILING DATE **GROUP** THE WARE February 19, 2004 Unknown

U.S. PATENT DOCUMENTS						
EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE (IF APPROPRIATE)
Or	5,087,586	2/11/92	Chan et al.			
W	5,447,884	9/5/95	Fahey et al.			
OY	5,492,858	2/20/096	Bose et al.			-
ON	5,702,976	12/30/97	Schuegraf et al.			
CX	6,027,982	2/22/00	Peidous et al.			
ON	6,037,238	3/14/00	Chang et al.			
08	6,518,148 B1	2/11/03	Cheng et al.			
OK	6,657,276 B1	12/2/03	Karlsson et al.			
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FOREIGN PATENT DOCUMENTS							
EXAMINER	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
INITIAL						YES	NO
		<u> </u>					

EXAMINER INITIAL	OTHER DOCUMENTS (INCLUDING AUTHOR, TITLE, DATE, PERTINENT PAGES, ETC.)				
ON	Peters, Laura, "Choices and Challenges for Shallow Trench Isolation," <u>Semiconductor International</u> , Website www.ree-electronics.com, 6 pages, April 1, 1999.				
OY	Advertisement entitled "Polysilazane SODs Spinfil™ 400 Series for STI/PMD Application."				

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I EXAMINER: INTIAL IF CITATION CONSIDERED, WHETHER OR NOT CITATION IS IN CONFORMANCE WITH MPEP 609; DRAY IN CONFORMANCE AND NOT CONSIDERED, INCLUDE COPY OF THIS FORM WITH NEXT COMMUNICATION TO APPLICANT.